

CLAIMS

1. A method for electrolytically forming a material which comprises at least two elements, the method comprising:

5 providing an electrolytic cell comprising a cathode, an anode, and an electrolytic solution extending between the cathode and the anode; and electrolytically forming a metallic product with the electrolytic cell, the forming comprising primarily electrorefining of a first element of the at least two elements and primarily electrowinning of a second element of the at least two elements; the metallic product comprising the first and second elements.

2. The method of claim 1 wherein the electrolytic cell comprises two anodes; one of the two anodes comprising the first element, and the other of the two anodes not comprising the first element.

3. The method of claim 1 wherein the metallic product is formed on the cathode.

4. The method of claim 1 wherein one of the first and second elements comprises titanium.

5. The method of claim 1 wherein one of the first and second elements comprises titanium and the other of the first and second elements comprises hafnium.

6. The method of claim 1 wherein one of the first and second elements comprises titanium and the other of the first and second elements comprises zirconium.

7. The method of claim 1 wherein one of the first and second elements comprises titanium and the other of the first and second elements comprises vanadium.

8. The method of claim 1 wherein one of the first and second elements comprises titanium and the other of the first and second elements comprises aluminum.
9. The method of claim 1 wherein one of the first and second elements comprises titanium and the other of the first and second elements comprises chromium.
10. The method of claim 1 wherein one of the first and second elements comprises tantalum and the other of the first and second elements comprises zirconium.
11. The method of claim 1 wherein one of the first and second elements comprises tantalum and the other of the first and second elements comprises chromium.
12. The method of claim 1 wherein one of the first and second elements comprises tantalum and the other of the first and second elements comprises nickel.
13. The method of claim 1 wherein one of the first and second elements comprises tantalum.
14. The method of claim 1 wherein one of the first and second elements comprises titanium and wherein the other of the first and second elements comprises tantalum.
15. The method of claim 1 wherein the first element comprises titanium and wherein the second element comprises tantalum.
16. The method of claim 1 wherein the first element comprises tantalum and wherein the second element comprises titanium.

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23. The method of claim 19 further comprising shaping the metallic product into a physical vapor deposition target.

5 24. A method for electrolytically forming a material which comprises at least two elements, the method comprising:

providing an electrolytic cell comprising a cathode, at least two anodes, and an electrolytic solution extending between the cathode and the at least two anodes; the electrolytic solution comprising a compound which includes a second element; and

10 electrolytically forming a metallic product with the electrolytic cell; the metallic product comprising a mixture of the first and second elements; one of the at least two anodes being operated at a different voltage than an other of the at least two anodes during the electrolytically forming of the metallic product.

15 25. The method of claim 24 further comprising shaping the metallic product into a physical vapor deposition target.

20 26. A method for electrolytically forming a product which comprises a mixture of tantalum and titanium, the method comprising:

providing an electrolytic cell comprising a cathode, an anode, and an electrolytic solution extending between the cathode and the anode; the anode comprising titanium and the electrolytic solution comprising a tantalum-containing compound; and

25 electrolytically forming a metallic product with the electrolytic cell, the metallic product comprising a mixture of titanium from the anode and tantalum from the tantalum-containing compound.

27. The method of claim 26 wherein the tantalum-containing compound is K_2TaF_7 .

28. The method of claim 26 wherein the electrolytic solution is maintained at a temperature of from about 700°C to about 850°C during the electrolytically forming of the metallic product.
- 5 29. The method of claim 26 wherein the electrolytic solution is maintained at a temperature of from about 700°C to about 750°C during the electrolytically forming of the metallic product.
- 10 30. The method of claim 26 further comprising shaping the metallic product into a physical vapor deposition target.
31. The method of claim 26 further comprising pressing and sintering the metallic product.
- 15 32. The method of claim 26 further comprising subjecting the metallic product to forces to reduce an average grain size present within the metallic product.
33. A material which comprises a mixture of tantalum and titanium; and which is at least 99.9 weight percent tantalum and titanium.
34. The material of claim 33 comprising at least about 50 weight percent titanium.
35. The material of claim 33 comprising greater than 0 weight percent tantalum and less than or equal to about 12 weight percent tantalum.
- 25 36. The material of claim 33 comprising greater than or equal to about 7 weight percent tantalum and less than or equal to about 12 weight percent tantalum.

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46. The material of claim 42 comprising tantalum to a concentration of greater than or equal to about 25 weight percent and less than or equal to about 50 weight percent.
47. The material of claim 42 comprising tantalum to a concentration of greater than or equal to about 50 weight percent and less than or equal to about 75 weight percent.
48. The material of claim 42 comprising tantalum to a concentration of greater than or equal to about 75 weight percent and less than or equal to about 95 weight percent.
49. The material of claim 42 comprising titanium to a concentration of greater than or equal to about 5 weight percent and less than or equal to about 95 weight percent.
50. The material of claim 42 comprising titanium to a concentration of greater than or equal to about 5 weight percent and less than or equal to about 25 weight percent.
51. The material of claim 42 comprising titanium to a concentration of greater than or equal to about 25 weight percent and less than or equal to about 50 weight percent.
52. The material of claim 42 comprising titanium to a concentration of greater than or equal to about 50 weight percent and less than or equal to about 75 weight percent.
53. The material of claim 42 comprising titanium to a concentration of greater than or equal to about 75 weight percent and less than or equal to about 95 weight percent.
54. The material of claim 42 comprising hafnium to a concentration of greater than or equal to about 5 weight percent and less than or equal to about 95 weight percent.

55. The material of claim 42 comprising hafnium to a concentration of greater than or equal to about 5 weight percent and less than or equal to about 25 weight percent.
56. The material of claim 42 comprising hafnium to a concentration of greater than or equal to about 25 weight percent and less than or equal to about 50 weight percent.
57. The material of claim 42 comprising hafnium to a concentration of greater than or equal to about 50 weight percent and less than or equal to about 75 weight percent.
58. The material of claim 42 comprising hafnium to a concentration of greater than or equal to about 75 weight percent and less than or equal to about 95 weight percent.
59. The material of claim 42 comprising niobium to a concentration of greater than or equal to about 5 weight percent and less than or equal to about 95 weight percent.
60. The material of claim 42 comprising niobium to a concentration of greater than or equal to about 5 weight percent and less than or equal to about 25 weight percent.
61. The material of claim 42 comprising niobium to a concentration of greater than or equal to about 25 weight percent and less than or equal to about 50 weight percent.
62. The material of claim 42 comprising niobium to a concentration of greater than or equal to about 50 weight percent and less than or equal to about 75 weight percent.
63. The material of claim 42 comprising niobium to a concentration of greater than or equal to about 75 weight percent and less than or equal to about 95 weight percent.

5 65. The material of claim 42 comprising zirconium to a concentration of greater than or equal to about 5 weight percent and less than or equal to about 25 weight percent.

67. The material of claim 42 comprising zirconium to a concentration of greater than or equal to about 50 weight percent and less than or equal to about 75 weight percent.

68. The material of claim 42 comprising zirconium to a concentration of greater than or equal to about 75 weight percent and less than or equal to about 95 weight percent.

69. The material of claim 42 being in the shape of a PVD target.

70. A PVD target comprising tantalum to a concentration of greater than or equal to about 5 weight percent and less than or equal to about 95 weight percent.

71. The PVD target of claim 70 comprising the tantalum to a concentration of less than or equal to about 50 weight percent.

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